

## DECLARATION FOR PATENT APPLICATION

62004066US  
(05S0188P)

As a below named inventor, I declare :

that I verily believe myself to be the original, first and sole (if only one individual inventor is listed below) or an original, first and joint inventor (if more than one individual inventor is listed below ) of the invention in

## NITRIDE SEMICONDUCTOR LASER ELEMENT

the specification of which is attached hereto unless the following box is checked.

☒ was filed on March 10, 2005 as United States Application  
or PCT International Application No. PCT/JP2005/004249 , and  
was amended on \_\_\_\_\_ (if applicable).

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.  
I acknowledge the duty to disclose information of which is material to patentability as defined in 37 CFR 1.56.

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or 365(b) of any foreign application(s) for patent or inventor's certificate, or 35 U.S.C. 365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed:

Country	Category	Application Number	Filing Date	Priority Claim
Japan	Patent	2004-092656	March 26, 2004	Yes
Japan	Patent	2005-057761	March 2, 2005	Yes

I hereby appoint as my attorneys, with full power of substitution and revocation, to prosecute this application and transact all business in the Patent and Trademark Office connected therewith the practitioners at

Customer Number : 23117

of Nixon & Vanderhye P.C.. Please address all correspondence and telephone communications to the address and telephone number for this Customer Number.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

DECLARATION FOR PATENT APPLICATION

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(05S0188P)

I declare further that my citizenship, residence and mailing address are as stated below above my name:

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September 13, 2006

Akira Kitano

Date:

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Date:

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September 13, 2006

Hiroaki Matsumura

Date: